

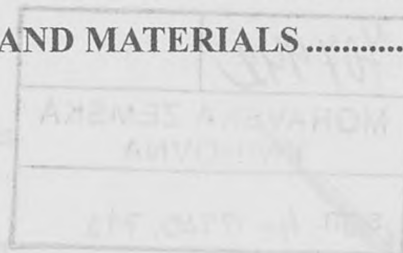
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MASTER MODULE 1

PRESSURE SENSORS

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MASTER MODULE 2

OPTICAL SENSORS

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MASTER MODULE 3

FLOW SENSORS

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Preface

You are a producer of soft drinks and you want to know at any point how many liters per hour you produce. Or your company discharges waste water on which taxes are levied per liter. These are only two everyday examples in which flow measurement plays an important part. The thousands of applications of flow meters tell us that they are one of the most important industrial measurements. We attempt to give you an idea of the different principles that are used and of the characteristics and properties of each method.

MASTER MODULE 4

SENSOR BUSES, INTELLIGENT SENSORS

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MASTER MODULE 5

ACCELEROMETERS AND INCLINOMETERS

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